

<b>Notice of References Cited</b>	Application/Control No. 10/565,806		Applicant(s)/Patent Under Reexamination STELTER, MICHAEL	
	Examiner Kwang Han		Art Unit 1795	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,057,054	05-2000	Barton et al.	429/42
*	B	US-6,649,097	11-2003	Sasaki et al.	264/102
*	C	US-6,921,602	07-2005	Diez et al.	429/36
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
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#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
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#### NON-PATENT DOCUMENTS

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